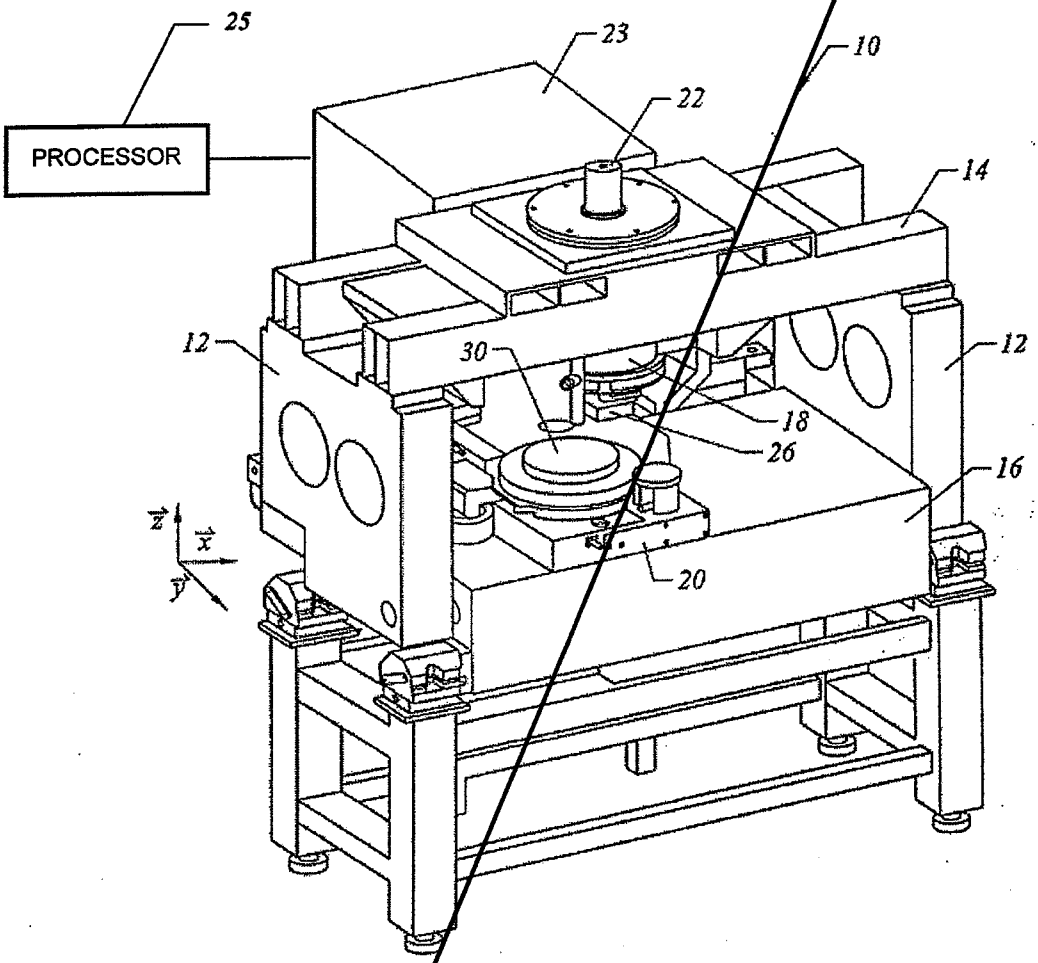


Fig. 1

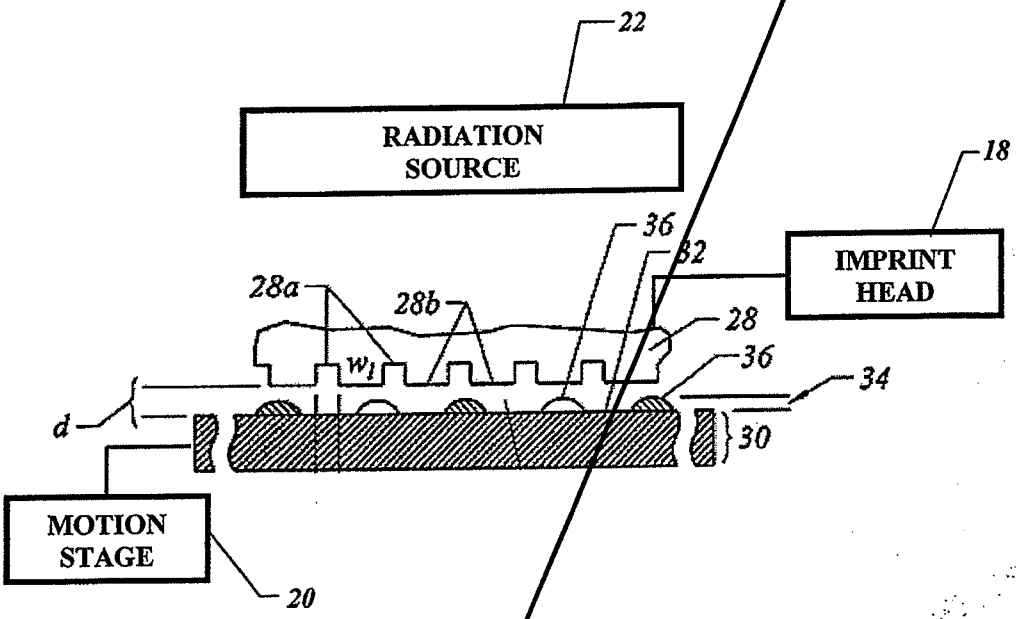

22
RADIATION SOURCE
18
IMPRINT HEAD
36
32
28a
28b
28
36
34
w_1
d
30
MOTION STAGE
20

Fig. 2

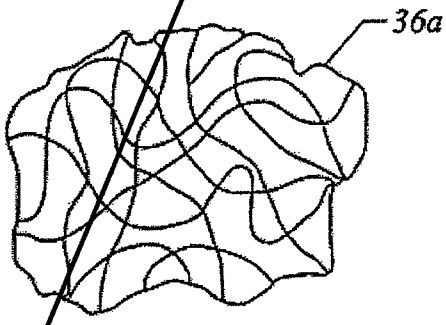

36a

Fig. 3

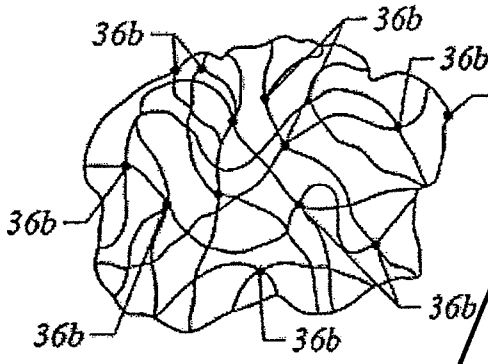


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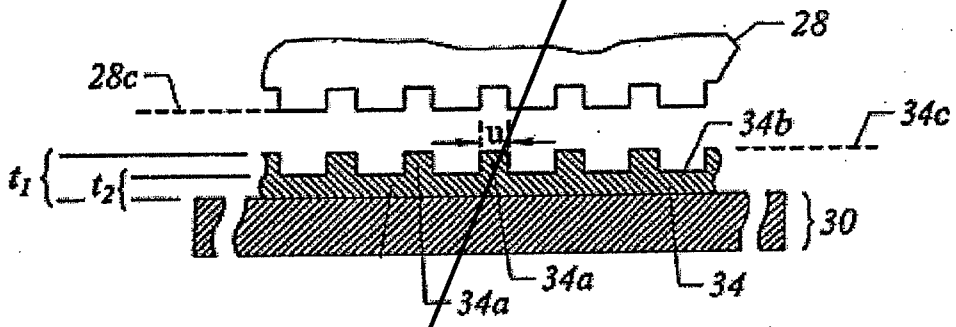


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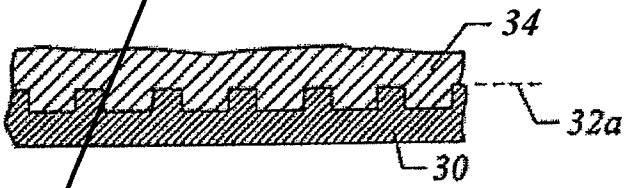


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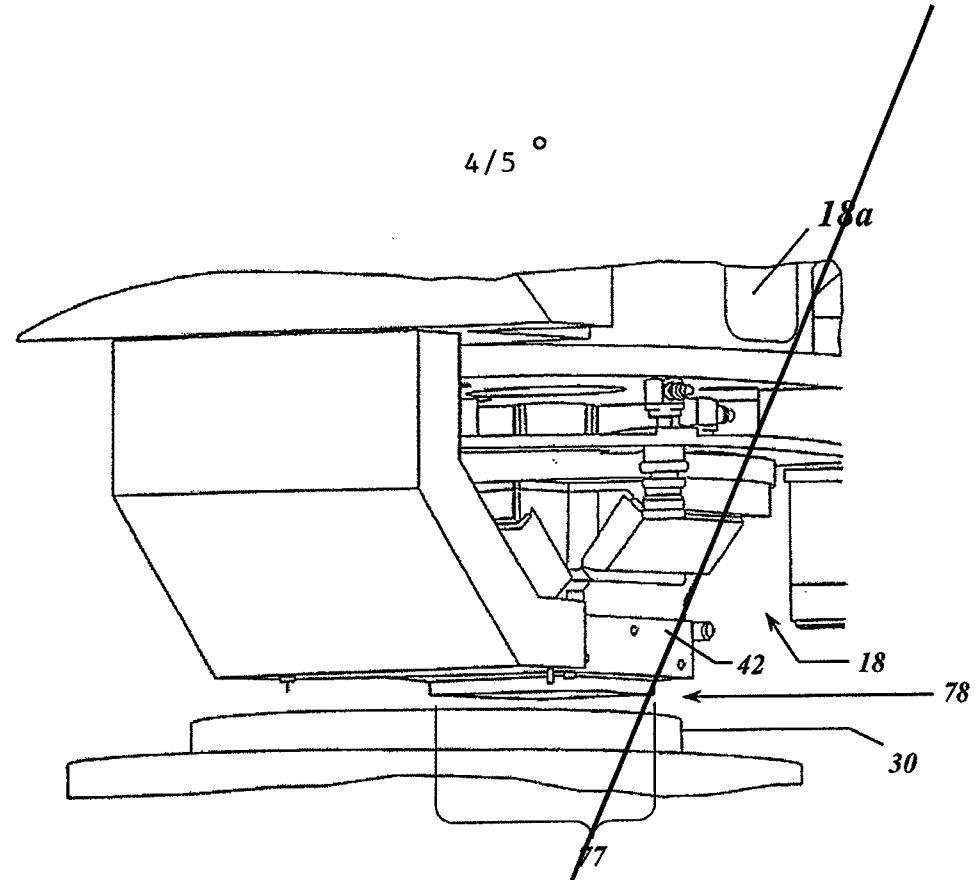

18a
42
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77

Fig. 7

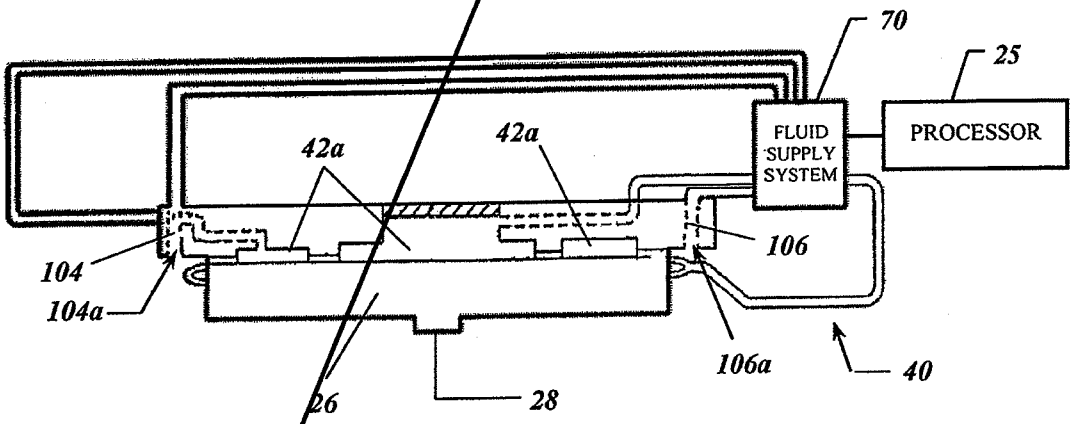

70
25
FLUID SUPPLY SYSTEM
PROCESSOR
42a
42a
106
104
104a
106a
40
26
28

Fig. 8

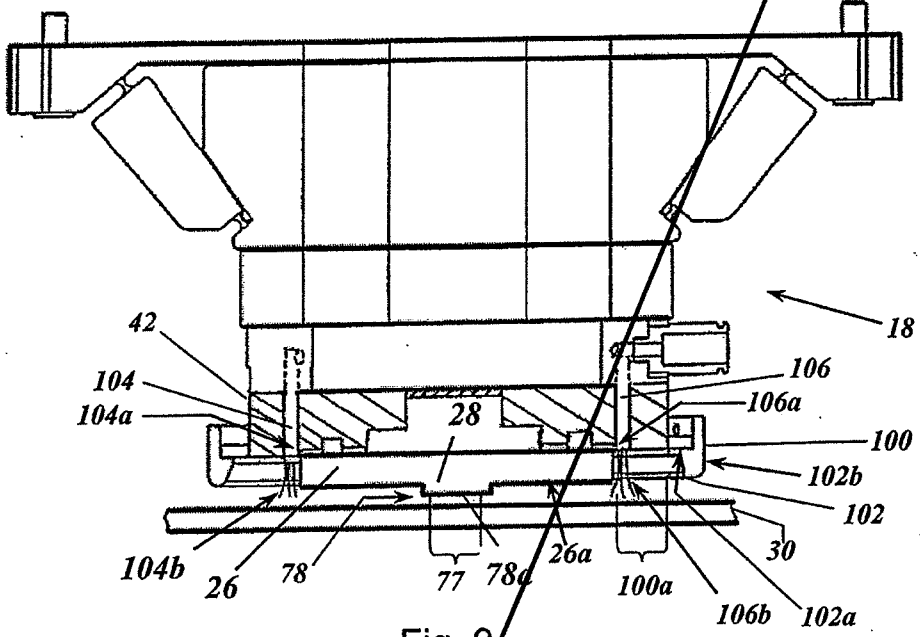

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Fig. 9

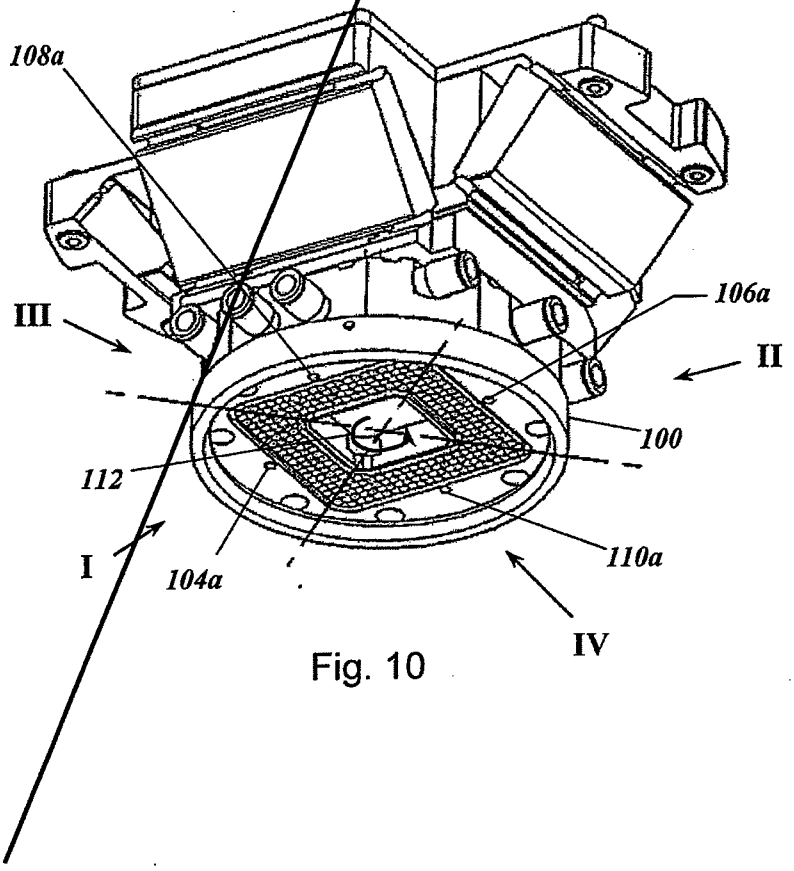

108a
106a
III
II
100
112
I
104a
110a
IV

Fig. 10

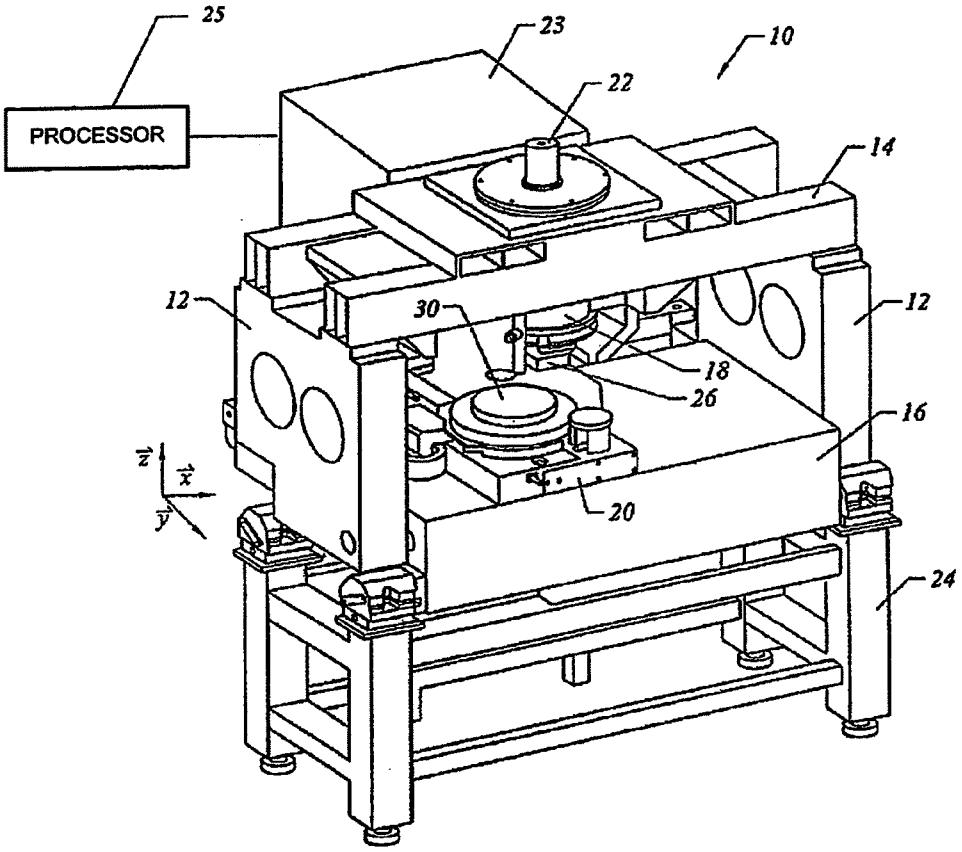


Fig. 1

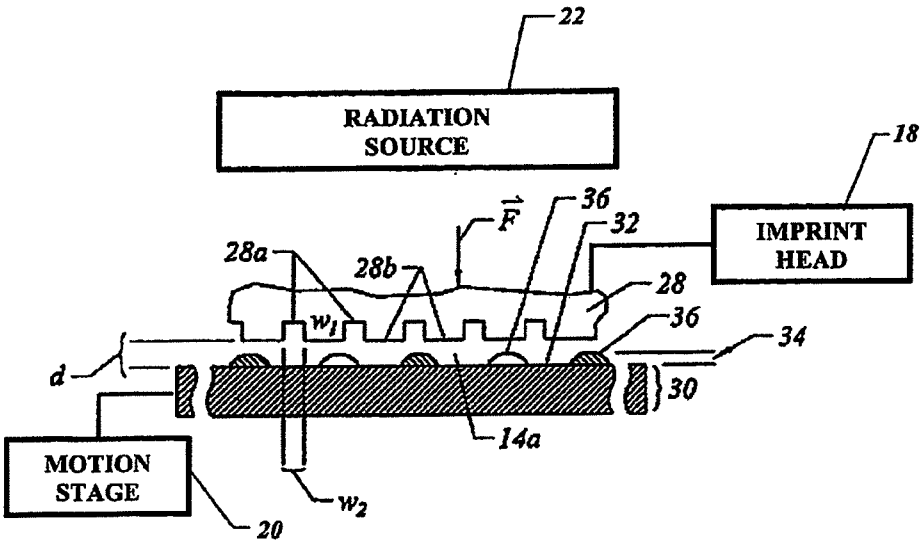

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MOTION STAGE
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Fig. 2

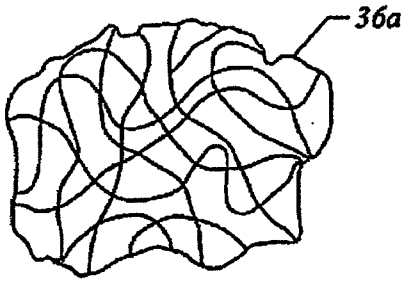

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Fig. 3

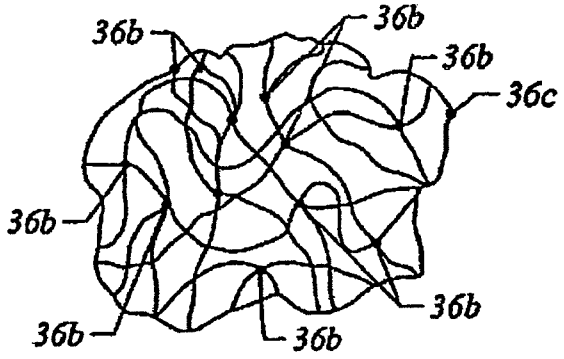


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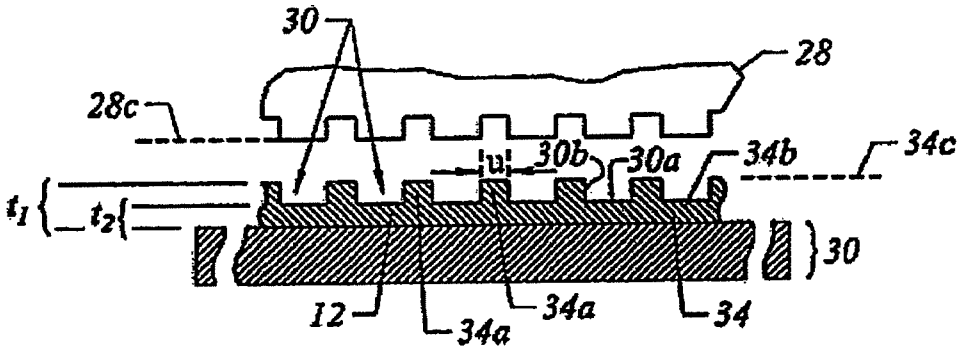


Fig. 5

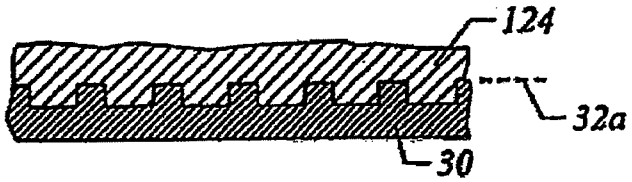


Fig. 6

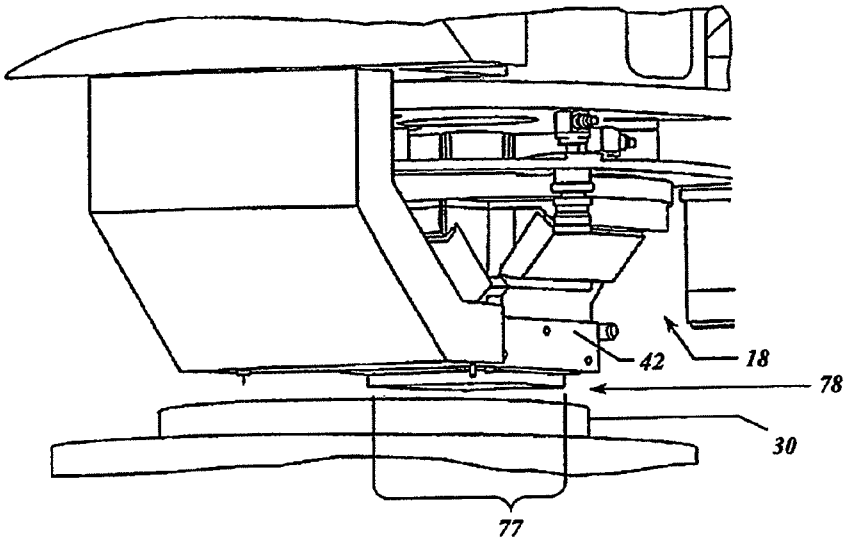

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Fig. 7

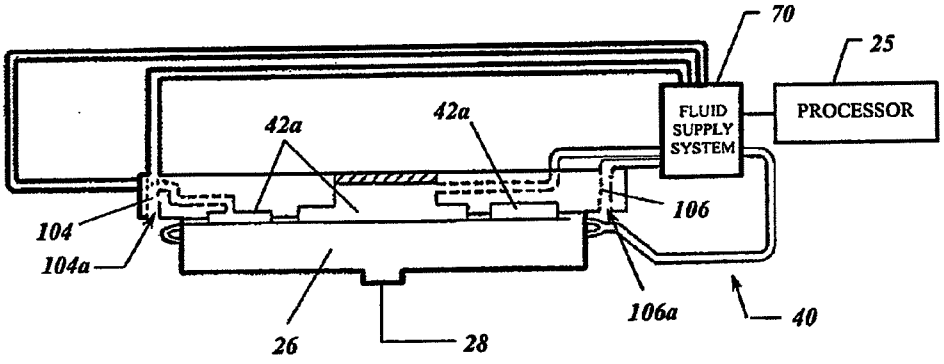

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FLUID SUPPLY SYSTEM
PROCESSOR
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Fig. 8

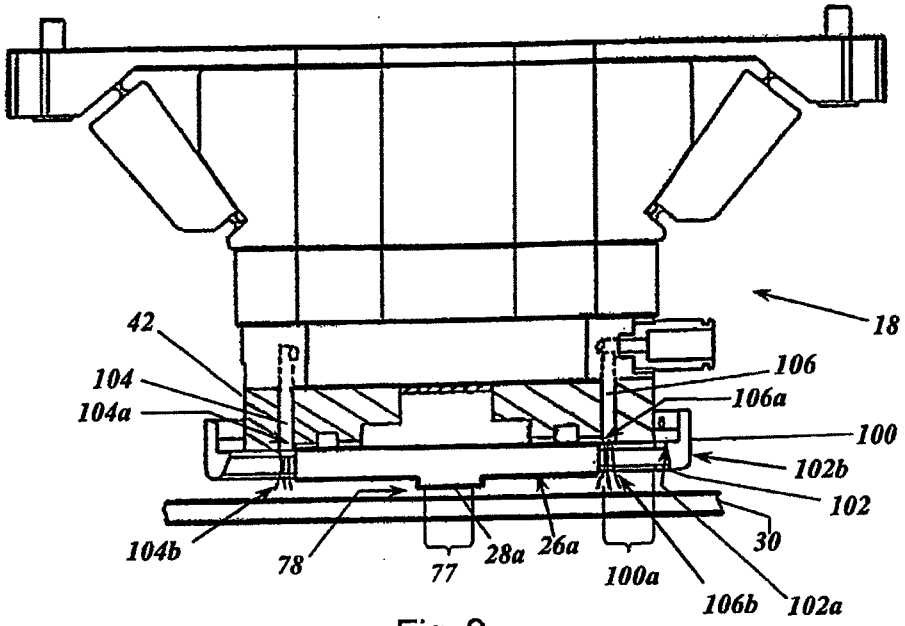

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Fig. 9

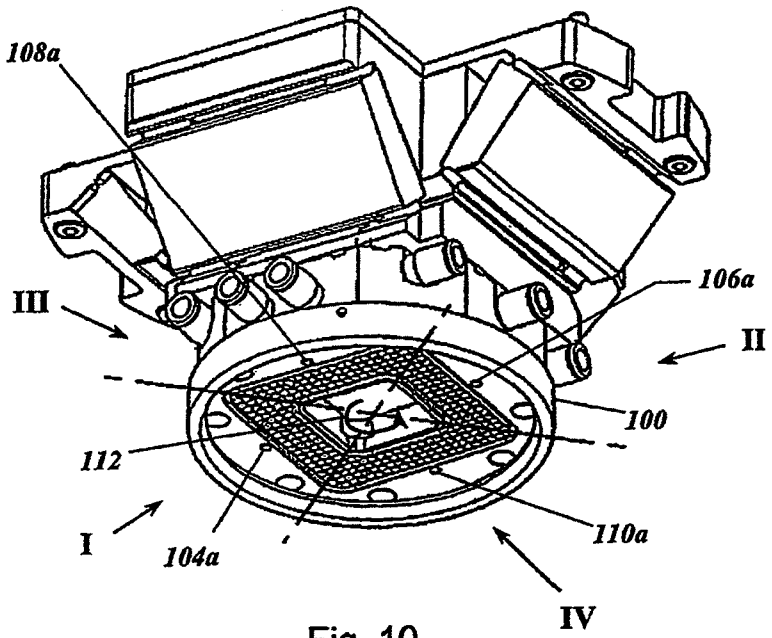

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IV

Fig. 10